

# CCD area image sensors



S16000-1007, S16001-1007S

## High sensitivity in the near infrared region: QE=36% ( $\lambda=1000$ nm), back-thinned type

This FFT-CCD for measurement has improved sensitivity in the near infrared region of 800 nm or above. In addition to having near infrared high sensitivity, it can be used as an image sensor having a long side aligned along the height direction of the photosensitive area by doing the binning operation, which makes it suitable as a detector for Raman spectroscopy. The binning operation offers significant improvement in S/N and signal processing speed compared with methods by which signals are digitally added by an external circuit.

Pixel size is  $24 \times 24 \mu\text{m}$  and the photosensitive area size is  $24.576$  (H)  $\times$   $2.928$  (V) mm (number of effective pixels:  $1024 \times 122$  pixels). Pin layout and drive conditions are the same as the Hamamatsu S7030/S7031 series.

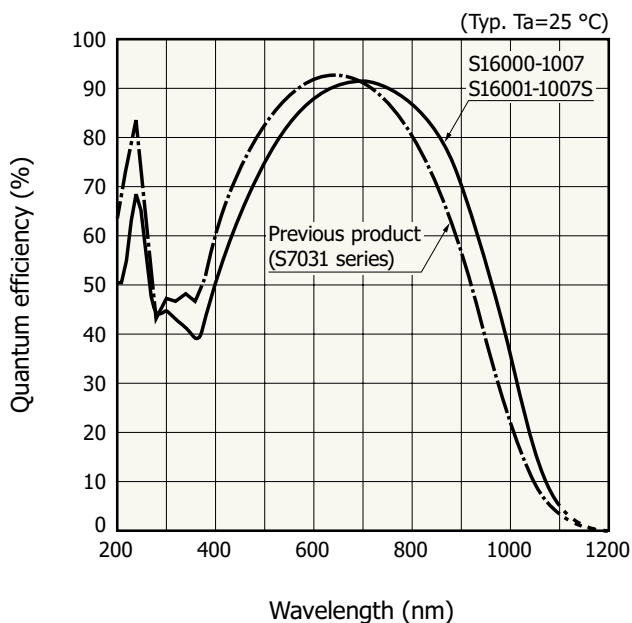
### Features

- High near infrared sensitivity: QE=36% ( $\lambda=1000$  nm)
- Pixel size:  $24 \times 24 \mu\text{m}$
- Line/pixel binning capabilities
- MPP operation

### Applications

- Raman spectroscopy, etc.

### Spectral response (without window)\*1



KMPDB0648EA

\*1: Sensitivity decreases depending on the spectral transmittance characteristics of the window material.

▣ Structure

Parameter	S16000-1007	S16001-1007S	Unit
Pixel size (H × V)	24 × 24		μm
Total number of pixels (H × V)	1044 × 128		pixels
Number of effective pixels (H × V)	1024 × 122		pixels
Image size (H × V)	24.576 × 2.928		mm
Vertical clock	Two-phase		-
Horizontal clock	Two-phase		-
Output circuit	One-stage MOSFET source follower		-
Package	24-pin ceramic DIP (refer to dimensional outlines)		-
Window material*2	Quartz glass*3	AR-coated sapphire*4	-
Cooling	Non-cooled	One-stage TE-cooled	-

\*2: Window-less type (ex. S16000-1007N) is available upon request. (Temporary window is fixed by tape to protect the CCD chip.)

\*3: Resin sealing

\*4: Hermetic sealing

▣ Absolute maximum ratings (Ta= 25°C)

Parameter	Condition	Symbol	Min.	Typ.	Max.	Unit
Operating temperature*5	No dew condensation*6	Topr	-50	-	+50	°C
Storage temperature	No dew condensation*6	Tstg	-50	-	+70	°C
Output transistor drain voltage		VOD	-0.5	-	+25	V
Reset drain voltage		VRD	-0.5	-	+18	V
Vertical input source voltage		VISV	-0.5	-	+18	V
Horizontal input source voltage		VISH	-0.5	-	+18	V
Vertical input gate voltage		VIG1V, VIG2V	-10	-	+15	V
Horizontal input gate voltage		VIG1H, VIG2H	-10	-	+15	V
Summing gate voltage		VSG	-10	-	+15	V
Output gate voltage		VOG	-10	-	+15	V
Reset gate voltage		VRG	-10	-	+15	V
Transfer gate voltage		VTG	-10	-	+15	V
Vertical shift register clock voltage		VP1V, VP2V	-10	-	+15	V
Horizontal shift register clock voltage		VP1H, VP2H	-10	-	+15	V
Maximum current of TE-cooler*7	Tc*8=Th*9=25 °C	Imax	-	-	3.0	A
Maximum voltage of TE-cooler	Tc*8=Th*9=25 °C	Vmax	-	-	3.6	V
Maximum temperature of heat radiation side	*10	-	-	-	70	°C
Thermistor power dissipation		Pd_th			1.3	mW

\*5: Package temperature (S16000-1007), chip temperature (S16001-1007S)

\*6: When there is a temperature difference between a product and the surrounding area in high humidity environments, dew condensation may occur on the product surface. Dew condensation on the product may cause deterioration in characteristics and reliability.

\*7: When the current value exceeds Imax, the heat absorption rate begins to decrease due to the Joule heat. Note that this maximum current Imax is not the threshold for damaging the cooler. To protect the TE-cooler and maintain stable operation, the supply current should be less than 60% of this maximum current.

\*8: Temperature of the cooling side of the TE-cooler

\*9: Temperature of the heat radiation side of the TE-cooler

\*10: Vacuum condition

Note: Exceeding the absolute maximum ratings even momentarily may cause a drop in product quality. Always be sure to use the product within the absolute maximum ratings.

▣ Operating conditions (MPP mode, Ta=25 °C)

Parameter	Symbol	Min.	Typ.	Max.	Unit	
Output transistor drain voltage	VOD	18	20	22	V	
Reset drain voltage	VRD	11.5	12	12.5	V	
Output gate voltage	VOG	1	3	5	V	
Substrate voltage	VSS	-	0	-	V	
Test point	Vertical input source	VISV	-	VRD	-	V
	Horizontal input source	VISH	-	VRD	-	V
	Vertical input gate	VIG1V, VIG2V	-9	-8	-	V
	Horizontal input gate	VIG1H, VIG2H	-9	-8	-	V
Vertical shift register clock voltage	High	VP1VH, VP2VH	4	6	8	V
	Low	VP1VL, VP2VL	-9	-8	-7	
Horizontal shift register clock voltage	High	VP1HH, VP2HH	4	6	8	V
	Low	VP1HL, VP2HL	-9	-8	-7	
Summing gate voltage	High	VSGH	4	6	8	V
	Low	VSGL	-9	-8	-7	
Reset gate voltage	High	VRGH	4	6	8	V
	Low	VRGL	-9	-8	-7	
Transfer gate voltage	High	VTGH	4	6	8	V
	Low	VTGL	-9	-8	-7	
External load resistance	RL	20	22	24	kΩ	

▣ Electrical characteristic (Ta=25 °C)

Parameter	Symbol	Min.	Typ.	Max.	Unit
Signal output frequency	fc	-	0.25	1	MHz
Line rate	LR	-	160	387	Hz
Vertical shift register capacitance	CP1V, CP2V	-	3000	-	pF
Horizontal shift register capacitance	CP1H, CP2H	-	180	-	pF
Summing gate capacitance	CSG	-	30	-	pF
Reset gate capacitance	CRG	-	30	-	pF
Transfer gate capacitance	CTG	-	75	-	pF
Charge transfer efficiency*11	CTE	0.99995	0.99999	-	-
DC output level	Vout	14	16	18	V
Output impedance	Zo	-	3	4	kΩ
Power consumption*12	P	-	13	14	mW

\*11: Charge transfer efficiency per pixel, measured at half the saturation charge

\*12: Power consumption of the on-chip amp plus load resistance

**Electrical and optical characteristics (Ta=25 °C, unless otherwise noted)**

Parameter		Symbol	Min.	Typ.	Max.	Unit
Saturation output voltage		Vsat	-	Fw × CE	-	V
Saturation charge	Vertical	Fw	200	280	-	ke <sup>-</sup>
	Horizontal*13		800	1000	-	
Conversion efficiency		CE	1.8	2.2	-	μV/e <sup>-</sup>
Dark current (MPP mode)*14	25 °C	DS	-	200	1000	e <sup>-</sup> /pixel/s
	0 °C		-	20	100	
Readout noise*15		Nread	-	8	16	e <sup>-</sup> rms
Dynamic range*16	Line binning	Drange	100000	125000	-	-
	Area scanning		25000	35000	-	-
Photoresponse nonuniformity*17		PRNU	-	±3	±10	%
Spectral response range		λ	-	200 to 1100	-	nm
Blemish	Point defect*18	White spot	-	-	0	-
		Black spot	-	-	10	-
	Cluster defect*19		-	-	3	-
	Column defect*20		-	-	0	-

\*13: Linearity=±1.5%

\*14: Dark current nearly doubles for every 5 to 7 °C increase in temperature.

\*15: Using a Hamamatsu evaluation circuit (chip temperature=-40 °C, operating frequency=20 kHz)

\*16: Dynamic range = Saturation charge/Readout noise

\*17: Measured at half the saturation output using an LED light (peak emission wavelength: 470 nm)

$$\text{Photoresponse nonuniformity} = \frac{\text{Fixed pattern noise (peak to peak)}}{\text{Signal}} \times 100 [\%]$$

\*18: White spots

Pixels whose dark current is higher than 1 ke<sup>-</sup> after one-second integration at a cooling temperature of 0 °C

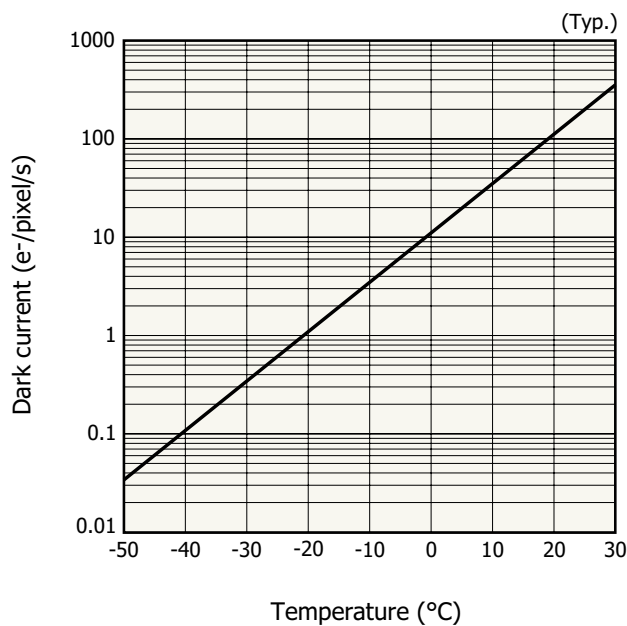
Black spots

Pixels whose sensitivity is lower than one-half of the average pixel output (measured with uniform light producing one-half of the saturation charge)

\*19: 2 to 9 contiguous pixel defects

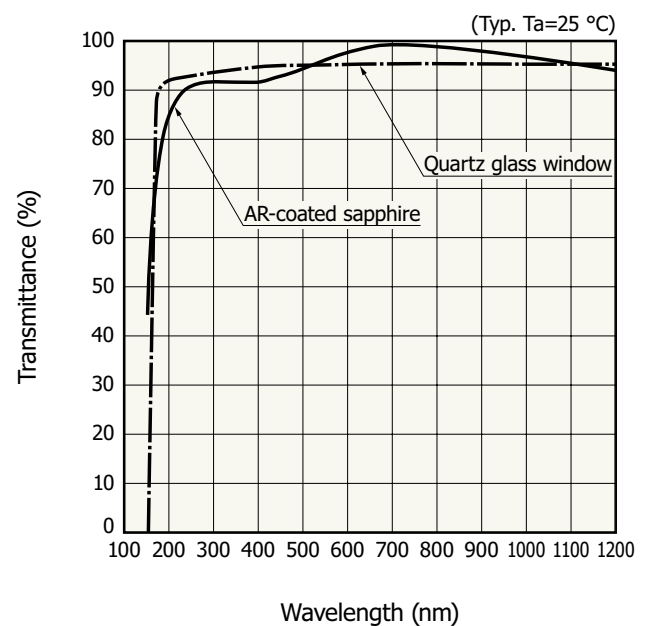
\*20: 10 or more contiguous pixel defects

**Dark current vs. temperature**



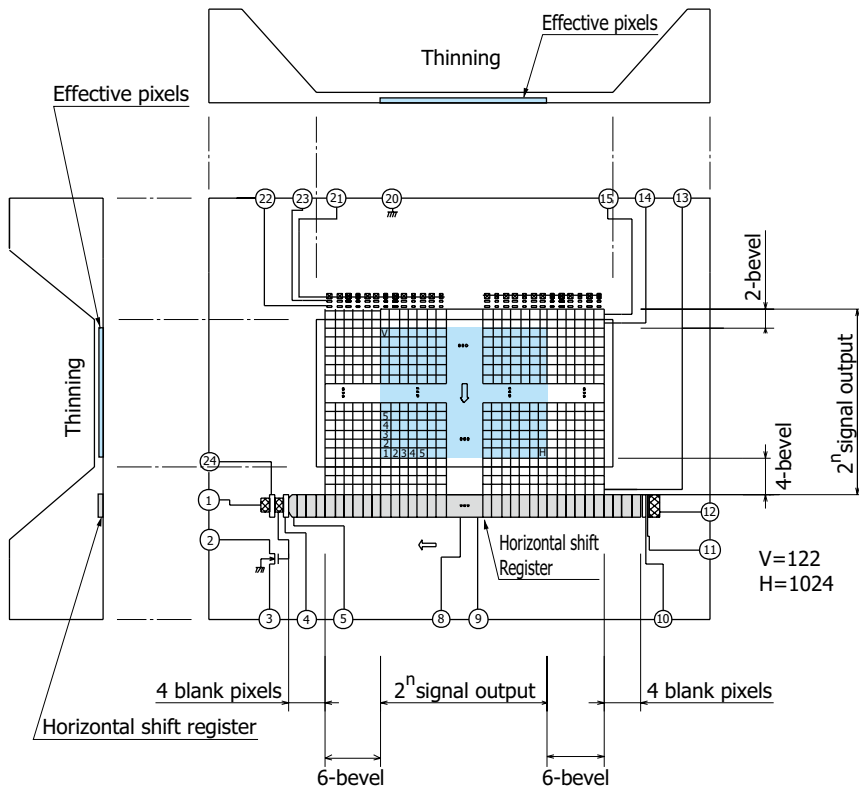
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**Spectral transmittance characteristics of window material**



KMPDB0110EA

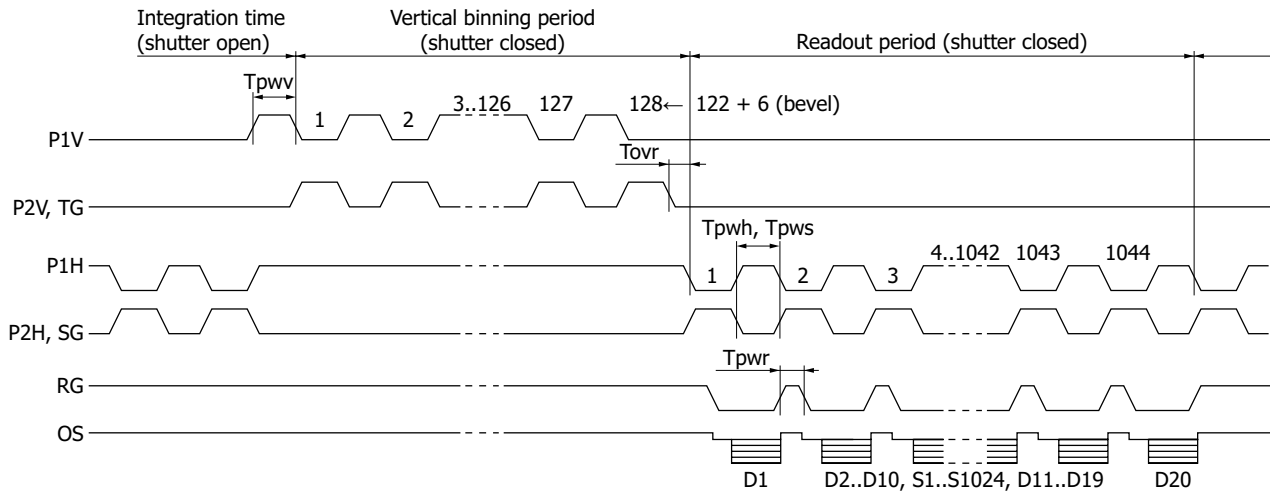
Device structure (conceptual diagram as viewed from top of dimensional outline)



Note: When viewed from the light input side, the horizontal shift register is covered by the thick area of the silicon (insensitive area), but long-wavelength light may pass through the insensitive silicon area. This light may be received by the horizontal shift register. Take measures such as shielding the light.

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**Timing chart (line binning)**



KMPDC0353EA

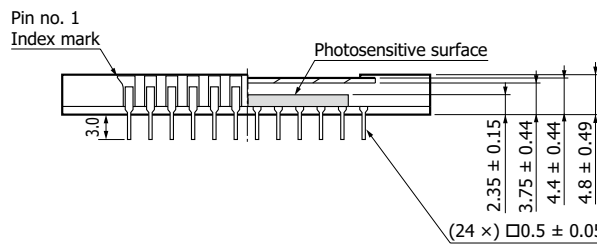
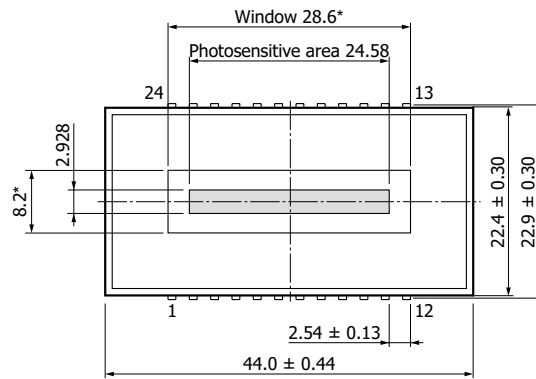
Parameter		Symbol	Min.	Typ.	Max.	Unit
P1V, P2V, TG*21	Pulse width	$T_{pwv}$	6	8	-	$\mu$ s
	Rise and fall times	$T_{prv}, T_{pfv}$	10	-	-	ns
P1H, P2H*21	Pulse width	$T_{pwh}$	500	2000	-	ns
	Rise and fall times	$T_{prh}, T_{pfh}$	10	-	-	ns
	Duty ratio	-	40	50	60	%
SG	Pulse width	$T_{pws}$	500	2000	-	ns
	Rise and fall times	$T_{prs}, T_{pfs}$	10	-	-	ns
	Duty ratio	-	40	50	60	%
RG	Pulse width	$T_{pwr}$	100	-	-	ns
	Rise and fall times	$T_{prr}, T_{pfr}$	5	-	-	ns
TG-P1H	Overlap time	$T_{ovr}$	3	-	-	$\mu$ s

\*21: Symmetrical clock pulses should be overlapped at 50% of maximum pulse amplitude.



Dimensional outlines (unit: mm)

S16000-1007

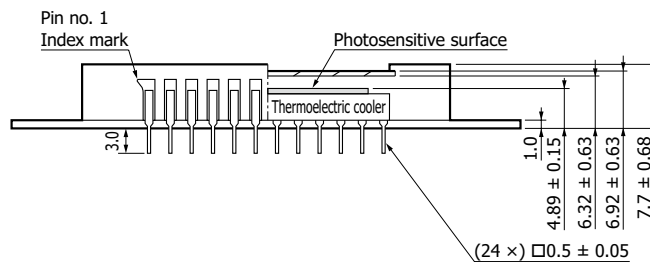
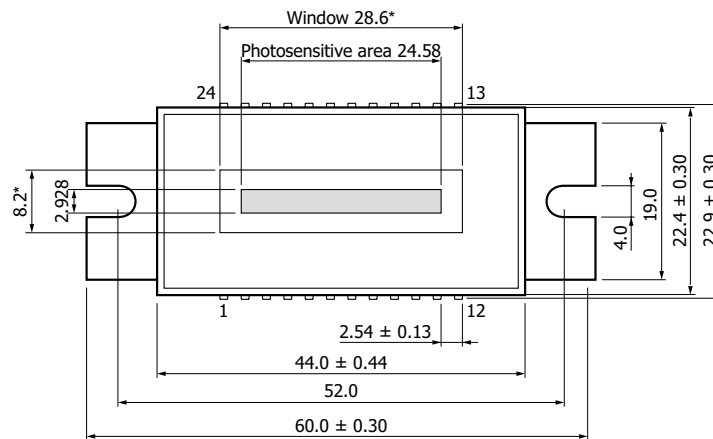


Weight: 12 g  
 Lead material: Kovar  
 Lead processing: Gold-plated  
 Window refractive index≈1.5

\* Size of window that guarantees the transmittance in the "Spectral transmittance characteristics of window material" graph

KMPDA0639EA

S16001-1007S



Weight: 39 g  
 Lead material: Kovar  
 Lead processing: Gold-plated  
 Window refractive index≈1.8

\* Size of window that guarantees the transmittance in the "Spectral transmittance characteristics of window material" graph

KMPDA0640EA



**Pin connections**

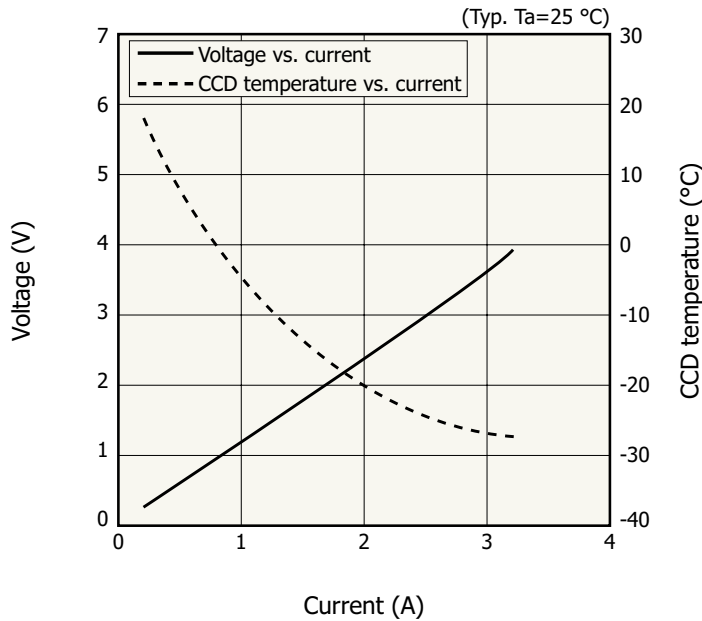
Pin no.	S16000-1007		S16001-1007S		Note (standard operation)
	Symbol	Function	Symbol	Function	
1	RD	Reset drain	RD	Reset drain	+12 V
2	OS	Output transistor source	OS	Output transistor source	R <sub>L</sub> =22 kΩ
3	OD	Output transistor drain	OD	Output transistor drain	+20 V
4	OG	Output gate	OG	Output gate	+3 V
5	SG	Summing gate	SG	Summing gate	Same timing as P2H
6	-		-		
7	-		-		
8	P2H	CCD horizontal register clock-2	P2H	CCD horizontal register clock-2	
9	P1H	CCD horizontal register clock-1	P1H	CCD horizontal register clock-1	
10	IG2H	Test point (horizontal input gate-2)	IG2H	Test point (horizontal input gate-2)	-8 V
11	IG1H	Test point (horizontal input gate-1)	IG1H	Test point (horizontal input gate-1)	-8 V
12	ISH	Test point (horizontal input source)	ISH	Test point (horizontal input source)	Connect to RD
13	TG* <sup>23</sup>	Transfer gate	TG* <sup>23</sup>	Transfer gate	Same timing as P2V
14	P2V	CCD vertical register clock-2	P2V	CCD vertical register clock-2	
15	P1V	CCD vertical register clock-1	P1V	CCD vertical register clock-1	
16	-		Th1	Thermistor	
17	-		Th2	Thermistor	
18	-		P-	TE-cooler (-)	
19	-		P+	TE-cooler (+)	
20	SS	Substrate (GND)	SS	Substrate (GND)	GND
21	ISV	Test point (vertical input source)	ISV	Test point (vertical input source)	Connect to RD
22	IG2V	Test point (vertical input gate-2)	IG2V	Test point (vertical input gate-2)	-8 V
23	IG1V	Test point (vertical input gate-1)	IG1V	Test point (vertical input gate-1)	-8 V
24	RG	Reset gate	RG	Reset gate	

\*23: Isolation gate between vertical register and horizontal register. In standard operation, TG should be applied the same pulse as P2V.

**Specifications of built-in TE-cooler (S16001-1007S, Typ., Vacuum condition)**

Parameter	Symbol	Condition	Specification	Unit
Internal resistance	Rint	Ta=25 °C	1.2	Ω
Maximum heat absorption*24	Qmax		5.1	W

\*24: This is a theoretical heat absorption level for correcting the temperature difference that occurs in the TE-cooler when the maximum current is supplied.



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**Specifications of built-in temperature sensor (S16001-1007S)**

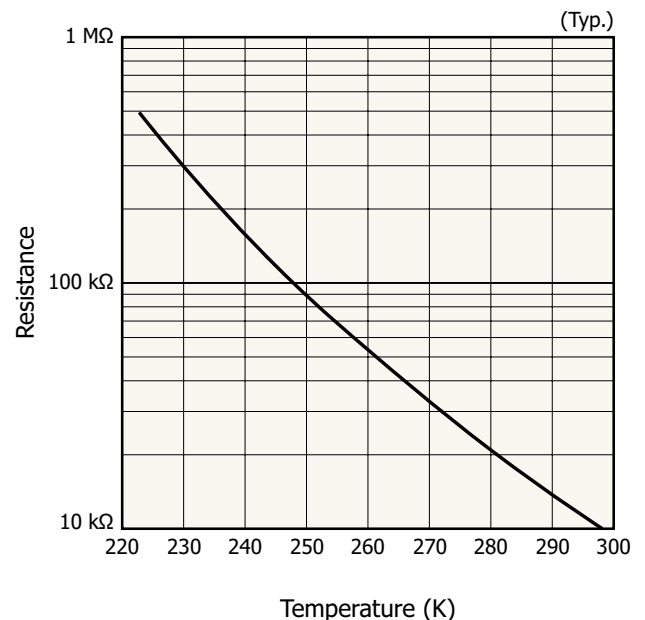
A thermistor chip is built into the same package with a CCD chip and monitors the operating CCD chip temperature. The relation between this thermistor's resistance and absolute temperature is expressed by the following equation.

$$R_{T1} = R_{T2} \times \exp \left( \frac{B}{T_1} - \frac{B}{T_2} \right)$$

- RT1: resistance at absolute temperature T1 [K]
- RT2: resistance at absolute temperature T2 [K]
- BT1/ T2: B constant [K]

The characteristics of the thermistor used are as follows.

- R298=10 kΩ
- B298/323=3450 K



KMPD80111EB

**Precautions**

- If the heat dissipation by the thermoelectric coolers during cooling is insufficient, the element temperature will increase and may cause physical damage to the product. Provide sufficient heat dissipation during cooling. As a measure to ensure heat dissipation, we recommend putting a material with high thermal conductivity (silicone, etc.) on the entire surface between the sensor and a heatsink (a metal block, etc.) and screwing it in place.
- When handling CCD sensors, always wear a wrist strap and also anti-static clothing, gloves, and shoes, etc. The wrist strap should have a protective resistor (about 1 MΩ) on the side closer to the body and be grounded properly. Using a wrist strap having no protective resistor is hazardous because you may receive an electrical shock if electric leakage occurs.
- Do not place the sensor directly on workbenches that may become charged with static electricity.
- Connect a ground wire to workbenches or floors in order to discharge static electricity.
- Connect a ground wire also to the tools such as tweezers and soldering irons to be used for handling the sensor.

It is not always necessary to provide all the electrostatic countermeasures stated above. Implement these countermeasures according to the extent of deterioration or damage that may occur.

**Temperature gradient rate for cooling or heating of element**

When using an external cooler for cooling CCDs, set the temperature gradient rate for cooling or heating the element to 5 K/minute or less.

**Recommended soldering conditions**

Parameter	Specification	Note
Soldering temperature	260 °C max. (once, within 5 seconds)	At least 2 mm away from lead roots

**Related information**

[www.hamamatsu.com/sp/ssd/doc\\_en.html](http://www.hamamatsu.com/sp/ssd/doc_en.html)

- Precautions
  - Disclaimer
  - Image sensors

- Technical information
  - CCD image sensors / Technical note

CCD multichannel detector heads C7040, C7041

**Features**

- C7040: for S7030 series, S16000-1007  
C7041: for S7031 series, S16001-1007S
- Area scanning or line binning operation
- Readout frequency: 250 kHz
- Readout noise: 20 e<sup>-</sup> rms
- ΔT=50 °C  
(ΔT varies depending on the cooling method.)

Input	Symbol	Specification
Supply voltage	VD1	+5 Vdc, 200 mA
	VA1+	+15 Vdc, +100 mA
	VA1-	-15 Vdc, -100 mA
	VA2	+24 Vdc, 30 mA
	VD2	+5 Vdc, 30 mA (C7041)
	Vp	+5 Vdc, 2.5 A (C7041)
	VF	+12 Vdc, 100 mA (C7041)
Master start	φms	HCMOS logic compatible
Master clock	φmc	HCMOS logic compatible, 1 MHz



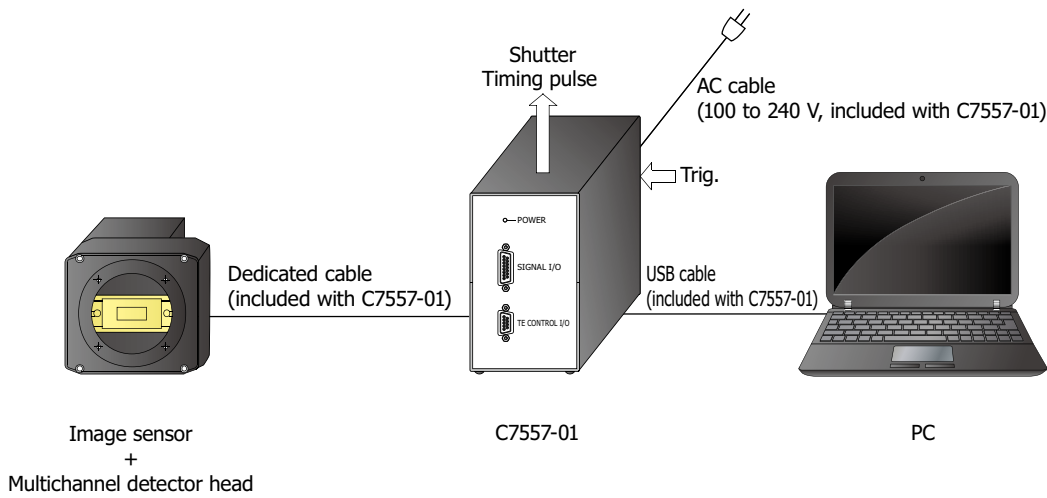
Multichannel detector head controller C7557-01

**Features**

- For control of multichannel detector head and data acquisition
- Easy control and acquisition using supplied software via USB interface



**Connection diagram**



**Note:**

- Shutter, etc. are not available.
- See the C7557-01 datasheet for compatible OS.

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The content of this document is current as of May 2022.

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